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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/776,685	02/10/2004	Mark C. Peterman	S02-295	3817	
30869 7	590 02/10/2006	EXAMINER			
LUMEN INTELLECTUAL PROPERTY SERVICES, INC. 2345 YALE STREET, 2ND FLOOR			DUDA, KA	DUDA, KATHLEEN	
PALO ALTO,			ART UNIT	PAPER NUMBER	
,			1756		

DATE MAILED: 02/10/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)	
Office Action Summary		10/776,685	PETERMAN, MARK C.	
		Examiner	Art Unit	
		Kathleen Duda	1756	
Period fo	The MAILING DATE of this communication ap	pears on the cover sheet with the c	orrespondence address	
A SH WHIC - Exte after - If NC - Failu Any	ORTENED STATUTORY PERIOD FOR REPL CHEVER IS LONGER, FROM THE MAILING D nations of time may be available under the provisions of 37 CFR 1. SIX (6) MONTHS from the mailing date of this communication. D period for reply is specified above, the maximum statutory period re to reply within the set or extended period for reply will, by statut reply received by the Office later than three months after the mailined patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNICATION 136(a). In no event, however, may a reply be tim will apply and will expire SIX (6) MONTHS from e, cause the application to become ABANDONE	N. nely filed the mailing date of this communication. D (35 U.S.C. § 133).	
Status				
2a)	Responsive to communication(s) filed on This action is FINAL . 2b) This Since this application is in condition for allowed closed in accordance with the practice under the prac	 s action is non-final. ince except for formal matters, pro		
Dispositi	ion of Claims			
4)⊠ 5)□ 6)⊠ 7)□ 8)□ Applicati 9)□ 10)□	Claim(s) 1-20 is/are pending in the application 4a) Of the above claim(s) is/are withdra Claim(s) is/are allowed. Claim(s) 1-20 is/are rejected. Claim(s) is/are objected to. Claim(s) are subject to restriction and/or are subject to restriction and/or are specification is objected to by the Examine The drawing(s) filed on is/are: a) according a complex and are subjected to by the Examine The drawing(s) filed on is/are: a) according to the Replacement drawing sheet(s) including the correct The oath or declaration is objected to by the Examine Th	er. cepted or b) objected to by the formula drawing(s) be held in abeyance. Section is required if the drawing(s) is objected.	e 37 CFR 1.85(a). jected to. See 37 CFR 1.121(d).	
Priority ı	ınder 35 U.S.C. § 119		4)	
12)[a)[Acknowledgment is made of a claim for foreign All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority document application from the International Burea See the attached detailed Office action for a list	ts have been received. ts have been received in Applicationity documents have been received u (PCT Rule 17.2(a)).	on No ed in this National Stage	
2) 🔲 Notic 3) 🔀 Inforr	t(s) e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08) r No(s)/Mail Date <u>02102004</u> .	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:		

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DETAILED ACTION

1. Claims 1-20 are pending in this application.

Claim Rejections - 35 USC § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 3. Claims 1, 3, 4, 7, 8, and 20 are rejected under 35 U.S.C. 102(b) as being clearly anticipated by Nakao ("Focus Monitoring Utilizing an Aperture in Cr Film on Backside of Photo Mask").

Nakao teaches a process of exposing using a mask with patterns on both sides of the mask substrate (see figures 1 and 2 – meets limitations of claim 1). Page 300, section 2, teaches that the mask features are formed of

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chromium (meets limitations of claims 3, 4, 7 and 9). Figure 2 depicts side two of the mask is closest to the wafer (meets limitations of claim 20).

4. Claims 1, 3, 4, 7, 8 and 20 are rejected under 35 U.S.C. 102(e) as being clearly anticipated by Morales (US 2004/0146139).

Morales teaches multilevel lithographic masks (paragraph 0003).

Paragraph 0010 teaches that the mask allows a variable range of radiation.

Patterns are formed on both sides of the mask (see paragraphs 0076 and 0079). It is taught that Group 4-12 metals are used to form the mask patterns. Group 4-12 metals include Cr and Fe. See the First Embodiment (paragraphs 0085 to 0096 and Figure 17) which teach that the mask is irradiated with radiation impinging on the first pattern and through the substrate to the second pattern before irradiating the target.

Claim Rejections - 35 USC § 103

- 5. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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6. Claims 2, 5, 6 and 9-19 rejected under 35 U.S.C. 103(a) as being unpatentable over Nakao or Morales in view of Lin (US Patent 6,664,011).

The teachings of Nakao and Morales have been discussed above.

Nakao and Morales do not teach transparent materials or the various pattern arrangements. These are taught by Lin.

Lin teaches phase-shifting masks which are used in submicron lithographic processes. Column 1, line 43, teaches the critical dimensions are in the 0.1 to 0.2 micron range. Claim 1 recites using masks with both opaque and transparent pattern to form the desired submicron pattern.

Therefore, it would have been obvious to one of ordinary skill in the art to have used transparent or opaque patterns to form submicron features because Lin teaches the conventionality of both patterns producing submicron features. The various propagation patterns recited in claims 13-16 are various patterns known in the art.

Conclusion

7. Any inquiry concerning this communication should be directed to Examiner K. Duda at (571) 272-1383. Official FAX communications should be sent to (571) 273-8300.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Mark Huff, can be reached at 571-272-1385.

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Kathleen Duda Primary Examiner Art Unit 1756